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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KOROMO SHIROTA ET AL.

Application No.: 09/677,867

Filed: October 3, 2000

For: INK JET HEAD SUBSTRATE

> HAVING HEAT GENERATING RESISTOR AND INK JET HEAD

AND RECORDING METHOD

USING SAME

July 17, 2003

Examiner: K. Feggins

Group Art Unit: 2861

Mail Stop DD

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT AND STATUS INQUIRY

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to a Korean Office Action (copy attached), mailed on June 30, 2003, which cites U.S. Patent No. 5,448,273 (Klein et al.). It is noted that that patent was cited in the Information Disclosure Statement submitted to the Office on July 31, 2001.

## STATUS INQUIRY

Since Applicants' attorneys have not received any communication from the U.S. Patent and Trademark Office since requesting withdrawal of the application from issue, Applicants respectfully request to be apprised of when they can expect to receive an action on this application.

## **CONCLUSION**

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

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